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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Jaehwan EUN, et.al.

SERIAL NO. : to be assigned

FILED : herewith

FOR : METHOD FOR PREPARING FILM STRUCTURE
COMPRISING FERROELECTRIC SINGLE CRYSTAL LAYER

EXAMINER: to be assigned

GROUP: to be assigned

Attention: Intial Patent Examination Division
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination, it is respectfully requested that claims 2, 5, and
12 in the present application be amended.